



035001. REI

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of:)
U.S. Patent No.: 5,803,975, issued 09/08/98)
Application No.: 09/657,971)
Filed: September 8, 2000)
For: MICROWAVE PLASMA)
PROCESSING APPARATUS)
AND METHOD THEREFOR)

Examiner: Luz L. Alejandro

Group Art Unit: 1763

June 21, 2002

Commissioner for Patents
Washington, D.C. 20231

PETITION UNDER 37 C.F.R. § 1.136(a)

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Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated December 21, 2001 for an additional two months from April 21, 2002 to June 21, 2002.

Submitted herewith is a check for \$810.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

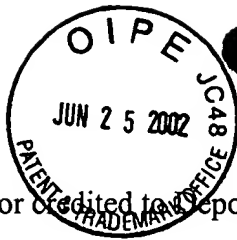
June 21, 2002
(Date of Deposit)

Lawrence S. Perry, Reg. No.: 3585

(Name of Attorney for Applicant)

Signature

June 21, 2002
Date of Signature



charged or credited to Deposit Account No. 06-1205. A duplicate copy of this petition is enclosed.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicant

Registration No. 31,865

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